

Notice of References Cited	Application/Control No. 09/684,529	Applicant(s)/Patent Under Reexamination LOGUE ET AL.	
	Examiner Eva Yi Zheng	Art Unit 2611	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,633,288	10-2003	Agarwal et al.	345/213
*	B	US-6,188,288	02-2001	Ragan et al.	331/16
*	C	US-6,445,234	09-2002	Yoon et al.	327/161
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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